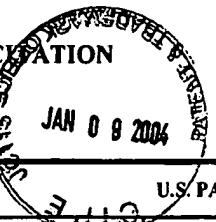


INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>				Docket Number (Optional) 072261.0007		Application Number 10/645,243	
				Applicant(s) Michael Trunz, et. al.			
				Filing Date August 21, 2003		Group Art Unit 2873	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JL	1	4,777,639	10/11/88	Whitehouse	372	107	12/15/86
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
Z	DE10137848A1	03/28/02	Germany	F02F	7/00	YES	NO
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
JL	3	Online Material Property Data Sheet; MatWeb.com, The Online Materials Database, XP-002262764, Aluminum 6061-T6; 6061-T651 Pub. Date 11/25/2003, pages 1-2.					
JL	4	Patent Abstracts of Japan, Vol. 2000, No. 01, January 31, 2000 and JP 11 269592A, ALUMINUM-HYPER-EUTECTIC SILICON ALLOW LOW IN HARDENING SENSITIVITY, AND ITS MANUFACTURE, Sumitomo Light Metal Ind. Ltd.					
EXAMINER <i>Jessie</i>				DATE CONSIDERED <i>6/3/04</i>			
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